

Docket No.: TCP-005

18545  
IAF20 RECEIVED 27 FEB 2006  
PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	
	:	Confirmation No.
Shojiro KOMATSU et al	:	
	:	
U.S. Patent Application No.: -----	:	Group Art Unit: -----
	:	
Filed: <i>herewith</i>	:	

For: FILM OF SP<sup>3</sup>-BONDED BORON NITRIDE HAVING A SELF-ORGANIZED  
SURFACE TEXTURE CAPABLE OF PROMOTING FIELD ELECTRON EMISSION,  
METHOD FOR PRODUCING THE SAME AND USE THEREOF

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows:

**Amendments to the Claims** begins on page 2 of this paper.

**Remarks** begins on page 6 of this paper.